

# LASER PROCESSING APPARATUS AND METHOD

## BACKGROUND OF THE INVENTION

The present invention relates to an apparatus and method  
5 for drilling holes in electronic circuit substrates using  
laser light.

Fig. 7 schematically shows the construction of a known  
laser processing apparatus, such as a CO<sub>2</sub> gas laser machining  
apparatus. Laser light 102 emitted from a laser oscillator 101  
is guided onto a workpiece 107 for forming micropores therein.  
A galvanometer 104 swings as it reflects received laser light  
102 onto an f $\theta$  lens 105 in a scanning manner. Thereupon, the  
f $\theta$  lens 105 converges the incident rays to form a focus spot  
106 at a predetermined location on the workpiece 107.

In general, laser light emitted from such laser  
oscillator contains light rays of various wavelengths and of  
various intensities. For achieving a high degree of precision  
in laser machining, the presence of light of various differing  
wavelengths presents a problem, particularly when employing an  
20 f $\theta$  lens, which is highly liable to chromatic aberration.

That is, when the laser light, which contains a plurality  
of light rays having different wavelengths  $\lambda_1$ ,  $\lambda_2$ ,  $\lambda_3$ , is  
emitted toward the f $\theta$  lens, chromatic aberration tends to occur  
because of the differences in wavelength of the laser light,  
25 since the refraction index of the f $\theta$  lens differs depending on

the wavelength. As a result, a plurality of focus spots are respectively formed by the discrete light rays of various wavelengths, as indicated by reference designators f1, f2, and f3 in Fig. 7. This is particularly so when the light incident position is spaced from the center of the f0 lens. The formation of a plurality of focus spots f1, f2, and f3 leads to unfavorable drilling results such as oval holes or a plurality of separate holes.

#### SUMMARY OF THE INVENTION

The present invention has been devised in light of the above-described problems encountered by the prior art, and it is an object of the invention to provide an improved laser processing method and an apparatus therefor, with which the formation of a plurality of or oval focus spots is inhibited, and drilling of favorable shapes is ensured.

A laser processing apparatus according to the invention includes:

a laser oscillator for emitting laser light;

an f0 lens positioned relative to the laser oscillator for converging the emitted laser light onto a workpiece; and

a wavelength selector interposed between the laser oscillator and the f0 lens for separating a light ray having a specified wavelength out of the laser light.

By providing the wavelength selector between the laser

oscillator and the  $f_0$  lens, a light ray having a specified wavelength is singled out from the laser light. The single light ray converged by the  $f_0$  lens forms only a single focus spot. Thus adverse effects of chromatic aberration caused by the  $f_0$  lens are eliminated, whereby the formation of deformed focus spots or a plurality of focus spots is inhibited, and the machining precision is enhanced.

These and other objects and characteristics of the present invention will become further clear from the following description with reference to the accompanying drawings.

#### BRIEF DESCRIPTION OF THE DRAWINGS

Fig. 1 is a schematic diagram illustrating the construction of a laser processing apparatus according to one embodiment of the present invention;

Fig. 2 is a schematic diagram illustrating a wavelength selector in one embodiment of the invention;

Fig. 3 is a schematic diagram illustrating a wavelength selector in another embodiment of the invention;

Fig. 4 is a schematic diagram illustrating a wavelength selector in yet another embodiment of the invention;

Fig. 5 is a schematic diagram illustrating a wavelength selector in a further embodiment of the invention;

Fig. 6 is a schematic diagram illustrating a modified example of the wavelength selector of Fig. 5; and

Fig. 7 is a schematic diagram illustrating the construction of a conventional laser processing apparatus.

#### DETAILED DESCRIPTION OF THE PREFERRED EMBODIMENTS

Preferred embodiments of the invention will be hereinafter described with reference to Fig. 1 through Fig. 6.

Fig. 1 is a schematic diagram illustrating a  $\text{CO}_2$  gas laser processing apparatus for drilling holes in a workpiece 7, which is an electronic circuit substrate in this embodiment, by emitting laser light thereonto. A laser oscillator 1 emits laser light 2 containing rays of various different wavelengths  $\lambda_1$ ,  $\lambda_2$ ,  $\lambda_3$  into a wavelength selector 3, which only passes light of specified wavelength  $\lambda_2$ . A galvanometer 4 rocks as indicated by the arrow in Fig. 1 so as to reflect received light into a f $\theta$  lens 5 in a scanning manner. The f $\theta$  lens 5 converges light to form a focus point 6 on the workpiece 7. Here, the focus point 6 takes the form of a true circle 62, because of the light having only the wavelength  $\lambda_2$ .

Fig. 2 is a conceptualized illustration of a wavelength selector 3 according to one embodiment of the invention. The wavelength selector 3 is mainly composed of a prism 31 and a spatial filter 39. The spatial filter 39 includes convex lenses 32, 33, which are focusing lenses, a shield 34 having a pin hole 34A, and reflection mirrors 8A, 8B.

The incident laser light 2 in the prism 31 disperses into

light rays 21, 22, 23 having different light axes because of the differing reflective indexes depending on their respective wavelengths  $\lambda_1$ ,  $\lambda_2$ ,  $\lambda_3$ . The three light rays 21, 22, 23 are reflected by the reflection mirrors 8A and 8B into the convex lens 32, whereby three separate focus points are formed by the convex lens 32. The shield 34 is disposed such that the pin hole 34A is positioned for passing only the light ray 22 having the predetermined wavelength  $\lambda_2$ , so that the other two light rays 21, 23 are shielded. The laser light 22 having the wavelength  $\lambda_2$  thus passes through the pin hole 34A and reaches the convex lens 33, by which it is emitted toward the galvanometer 4 shown in Fig. 1.

It is preferable to provide several ones of the above-described prism 31. By passing through the plurality of such prisms 31, separation of a desired one of light rays is more readily achieved.

Fig. 3 shows a wavelength selector 3 according to another embodiment of the invention. The wavelength selector 3 of this embodiment is mainly composed of a diffraction grating 35, a reflection mirror 8C, and a shield 36 having an opening 36A.

The incident laser light 2 containing light of various wavelengths  $\lambda_1$ ,  $\lambda_2$ ,  $\lambda_3$  is reflected by the diffraction grating 35 at various different angles in accordance with the wavelengths onto the reflection mirror 8C. The shield 36 is disposed such as to shield light rays 21, 23 while letting the

light ray 22 pass through its opening 36A. If the light rays of different wavelengths are in proximity to each other and the shield 36 alone can hardly provide the function of selecting a specified light ray, the arrangement shown in Fig.

2 including the shield 34 having the pin hole 34A and the convex lenses 32 and 33 may be substituted for the shield 36.

Fig. 4 shows a wavelength selector 3 according to yet another embodiment of the invention. The wavelength selector 3 of this embodiments is mainly composed of a wave plate 37 for polarizing laser light 2 into different phase shifts in accordance with the wavelengths, and a polarizer 38 for passing only the light polarized into a phase shift corresponding to a specified wavelength.

The difference in the phase shift of light rays of various wavelengths  $\lambda_1$ ,  $\lambda_2$ ,  $\lambda_3$  contained in the laser light 2 transmitting through the wave plate 37 appears as the difference in the transmittance at the polarizer 38. A wave plate of a multiple order can cause a distinct phase shift. Thus, by rotating the wave plate 37 within a surface having the light axis of the laser light 2 as a normal, specific light rays 21, 23 having unwanted wavelengths  $\lambda_1$ ,  $\lambda_3$  are reflected by the polarizer 38, so that only a desired one of light rays, having a specified wavelength  $\lambda_2$ , passes straight through the polarizer 38.

Fig. 5 is a conceptualized illustration of a wavelength

selector 3 according to a further embodiment of the invention,  
which is a modification of the above-described first  
embodiment of the invention illustrated in Fig. 2. According  
to this embodiment, laser light is passed through a prism not  
once but a number of times, so that the separation of a light  
ray having a specific wavelength is more precisely achieved.  
The wavelength selector 3 includes a spatial filter 39  
similarly to the first embodiment, and a wavelength separation  
system 51 having a first and a second reflection mirrors 52,  
53 and a prism 54 interposed between the reflection mirrors 52,  
53.

The incident laser light 2 transmitting the prism 54 of  
the wavelength separation system 51 is reflected by the first  
reflection mirror 52 and reenters the prism 54. The laser  
light is then reflected by the second reflection mirror 53 to  
enter the prism 54 third time. Thus the laser light 2 is  
transmitted through the prism 54 three times before being  
emitted from the wavelength separation system 51.

In this embodiment, for ease of explanation, it is  
assumed that the laser light 2 contains two light rays 21, 22  
having different wavelengths  $\lambda_1$ ,  $\lambda_2$ . By passing through the  
prism 54 three times as described above, the incident laser  
light 2 is separated into two light rays 21, 22 having  
different light axes, because of the different refractive  
indexes.



invention, adverse effects of chromatic aberration caused by the  $f_0$  lens are eliminated, whereby focus spots are prevented from being deformed or formed in plurality, ensuring higher degree of precision in laser machining.

5        Although the present invention has been fully described in connection with the preferred embodiment thereof, it is to be noted that various changes and modifications apparent to those skilled in the art are to be understood as included within the scope of the present invention as defined by the appended claims unless they depart therefrom.

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